



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : 10/623,866 Confirmation No. : 6399
First Named Inventor : Yoshihiro KATO
Filed : July 22, 2003
TC/A.U. : 1763
Examiner : Jeffrie R. Lund
Docket No. : 101246.52582US
Customer No. : 23911
Title : Plasma Process System and Plasma Process Method

REPLY

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In complete response to the Office Action dated June 23, 2005, the period of response having been extended to October 23, 2005 by the attached Petition for Extension of Time, please amend the above-captioned application as follows.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 7 of this paper.